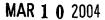
## **RECEIVED**



Attorney Docket SEL 170

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of )	
Hayakawa et al.	I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to:  Commissioner for Patents,  P.O. Box 1450, Alexandria, VA 22313-1450 on
Serial No.: 09/532,915 )	
Filed: March 22, 2000 )  For: Semiconductor Device and Method ) of Manufacturing The Same )  Art Unit: 2826 )	Matchil; 2004:11  (Date of Deposit)  Cristine M. Noll  Name of applicant, assignee, or Registered Rep.  Signature  Date
Examiner: Sefer, A.	

Commissioner for Patents P. O. Box 1450 Alexandria, VA 22313-1450

## **AMENDMENT F**

Sir:

In response to the Office Action of October 30, 2003, a one month extension of time being submitted herewith, please amend the above-identified application as follows:

